

Refine Search

Search Results -

Terms	Documents
L15 same microwave	15

Database:

US Pre-Grant Publication Full-Text Database
 US Patents Full-Text Database
 US OCR Full-Text Database
 EPO Abstracts Database
 JPO Abstracts Database
 Derwent World Patents Index
 IBM Technical Disclosure Bulletins

Search:

L22

Search History

DATE: Wednesday, August 10, 2005 [Printable Copy](#) [Create Case](#)

Set Name Query
 side by side

Hit Count Set Name
 result set

DB=USPT; PLUR=YES; OP=OR

<u>L22</u>	l15 same microwave	15	<u>L22</u>
<u>L21</u>	l20 and l14	24	<u>L21</u>
<u>L20</u>	l15 and l13	73	<u>L20</u>
<u>L19</u>	l15 and L18	1	<u>L19</u>
<u>L18</u>	ald or atomic adj layer	4221	<u>L18</u>
<u>L17</u>	l15 and l16	2	<u>L17</u>
<u>L16</u>	427/\$7.ccls.	86596	<u>L16</u>
<u>L15</u>	phased near3 array near3 radiation	193	<u>L15</u>
<u>L14</u>	l1 and L13	1	<u>L14</u>
<u>L13</u>	l10 or l11 or L12	56	<u>L13</u>
<u>L12</u>	campbell adj philip.in.	32	<u>L12</u>
<u>L11</u>	dando adj ross.in.	24	<u>L11</u>
<u>L10</u>	carpenter adj craig.in.	24	<u>L10</u>
<u>L9</u>	L8 and l13 and l14 and l6	7	<u>L9</u>
<u>L8</u>	l1 same L7	30	<u>L8</u>
<u>L7</u>	hydrogen or oxygen or nitrogen	707795	<u>L7</u>

<u>L6</u>	substrate	534239	<u>L6</u>
<u>L5</u>	l1 and l3 and L4	200	<u>L5</u>
<u>L4</u>	window	290049	<u>L4</u>
<u>L3</u>	coating or deposit\$3	870788	<u>L3</u>
<u>L2</u>	coating or deposition	645132	<u>L2</u>
<u>L1</u>	phase\$2 near3 microwave\$1	2429	<u>L1</u>

END OF SEARCH HISTORY

WEST Search History

DATE: Wednesday, August 10, 2005

Hide? Set Name Query Hit Count

DB=USPT; PLUR=YES; OP=OR

<input type="checkbox"/>	L16	l13 and l14 and L15	1
<input type="checkbox"/>	L15	ald or atomic adj layer adj deposition	1812
<input type="checkbox"/>	L14	chamber	570632
<input type="checkbox"/>	L13	l11 and L12	82
<input type="checkbox"/>	L12	semiconductor near2 (wafer or substrate)	119524
<input type="checkbox"/>	L11	l9 and L10	228
<input type="checkbox"/>	L10	hydrogen or nitrogen or oxygen	707795
<input type="checkbox"/>	L9	l5 and L8	264
<input type="checkbox"/>	L8	l3 and L7	1340
<input type="checkbox"/>	L7	microwave with window	2235
<input type="checkbox"/>	L6	l4 and L5	2
<input type="checkbox"/>	L5	427/\$7.ccls.	86596
<input type="checkbox"/>	L4	l2 and L3	35
<input type="checkbox"/>	L3	coating or deposit\$3	870788
<input type="checkbox"/>	L2	window same L1	84
<input type="checkbox"/>	L1	microwave near3 beam	2586

END OF SEARCH HISTORY

WEST Search History

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DB=USPT; PLUR=YES; OP=OR

<input type="checkbox"/>	L8	l7 and l2 and l3 and l4 and l5	6
<input type="checkbox"/>	L7	microwave with window	2235
<input type="checkbox"/>	L6	l1 and l2 and l3 and l4 and L5	1
<input type="checkbox"/>	L5	ald or atomic adj layer adj deposition	1812
<input type="checkbox"/>	L4	chamber	570632
<input type="checkbox"/>	L3	window near5 (quartz or mica or plastic)	10253
<input type="checkbox"/>	L2	hydrogen or nitrogen or oxygen	707795
<input type="checkbox"/>	L1	microwave near5 window	1562

END OF SEARCH HISTORY